

Applicants:	Yeo, <i>et al.</i>	Docket No.:	TSM03-0926
Serial No.:	10/685,938	Art Unit:	2894
Filed:	October 15, 2003	Examiner:	Movva, Amar
For:	Dummy Pattern for Silicide Gate Electrode		

AMENDMENT ACCOMPANYING RCE

Applicants respectfully submit the following amendments and remarks in response to Examiner's Office Action dated July 24, 2008, which Action is made final, and the Advisory Action mailed October 7, 2008. Applicants respectfully request that these amendments and remarks be entered in pursuant to the provisions of 37 C.F.R. § 1.114, and respectfully request reconsideration of the claims.